



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Dapeng Wang

**Serial No.:** 10/729,112

**Filed:** December 5, 2003

**For:** DEFORMABLE PAD FOR  
CHEMICAL MECHANICAL POLISHING

**Confirmation No.:** 3169

**Examiner:** R. Rose

**Group Art Unit:** 3723

**Attorney Docket No.:** 2269-3579.2US  
(98-0062.02/US)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 22, 2005  
Date

Signature

Shawnee MacDonald  
Name (Type/Print)

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 23, 2005, the three-month shortened statutory period for response to which expires on August 23, 2005.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.